| L Number | Hits | Search Text | DB | Time stamp |
|-------------|-------|--|-------------------|------------|
| 1 | 10 | (liner near4 sidewall) and gate and (cap | | |
| 2 | 1 | near nitride) | USPAT; | 2003/02/02 |
| | ļ | "car mitride, | US-PGPUB; | 14:00 |
| | 1 | | EPO; JPO; | |
| | | | DERWENT; | |
| | 8 | (liner near4 sidewall) same gate and (cap | IBM_TDB | |
| | | near nitride) | | 2003/02/02 |
| | | meat micride, | US-PGPUB; | 14:00 |
| | | | EPO; JPO; | |
| | | | DERWENT; | |
| 3 | 13789 | (self near aligned near contact) or SAC | IBM_TDB | |
| | | (Soll hear alighed hear contact) or SAC | USPAT; | 2003/02/02 |
| | | | US-PGPUB; | 14:02 |
| | | | EPO; JPO; | |
| | | ĺ | DERWENT; | |
| 4 | 2957 | ((self near aligned near contact) or SAC) | IBM_TDB | |
| | | and semiconductor | USPAT; | 2003/02/02 |
| | | | US-PGPUB; | 14:03 |
| | | | EPO; JPO; | |
| | | | DERWENT; | |
| 5 | 188 | (((self near aligned near contact) or | IBM_TDB | 0000/00/00 |
| | | SAC) and semiconductor) and ((interlayer | USPAT; | 2003/02/02 |
| | | near dielectric) or (PMD) same (voids or | US-PGPUB; | 15:10 |
| | | void or holes or hole)) | EPO; JPO; | |
| | | l local of mores of more | DERWENT; | |
| ; | 9 | ((gate near stack) same liner) same | IBM_TDB USPAT; | 2002/02/02 |
| | | spacer | US-PGPUB; | 2003/02/02 |
| | | • | EPO; JPO; | 14:58 |
| | | | DERWENT; | |
| | | | | |
| 7 | 19 | ((gate near stack) same liner) same | IBM_TDB USPAT; | 2002/02/02 |
| | | (spacer or spacers) | US-PGPUB; | 2003/02/02 |
| | | | EPO; JPO; | 15:00 |
| | | | DERWENT; | |
| | | | IBM TDB | |
| 3 | 43 | ((gate near stack) same liner) and | USPAT; | 2003/02/02 |
| | | (spacer or spacers) | US-PGPUB: | 15:02 |
| | | - ' | EPO; JPO; | 13.02 |
| | | | DERWENT; | |
| 1 | } | | IBM TDB | |
|) | 112 | ((gate near electrode) same liner) and | USPAT; | 2003/02/02 |
| | 1 | (spacer or spacers) | US-PGPUB; | 15:02 |
| ľ | 1 | | EPO; JPO; | -3.02 |
| | | ļ | DERWENT; | |
| | | | IBM TDB | |
| 0 | 166 | (((self near aligned near contact) or | USPAT; | 2003/02/02 |
| | | SAC) and semiconductor) and ((interlevel) | US-PGPUB; | 15:11 |
| | 1 | near dielectric) or (PMD) same (voids or | EPO; JPO; | |
| | | void or holes or hole)) | DERWENT; | |
| 1 | 7.4 | /!! 42057.61 !! . !! 40677777 !! !! | IBM_TDB | |
| <u> </u> | 14 | ("4285761" "4927777" "4977105" | USPĀT | 2003/02/02 |
| | - | "5132765" "5139968" "5262352" | | 15:13 |
| | | "5491100" "5545578" "5633522" | | |
| | 1 | "5698072" "5792684" "5994192" | | |
| 2 | 17 | "6001719" "6143611").PN. | | |
| - | 17 | ("5292677" "5472890" "5605864" | USPAT | 2003/02/02 |
| | ļ | "5654236" "5723381" "5728595" | | 15:25 |
| | | "5728596" "5731236" "5741396" "5759867" "5750000" "5760000" | | |
| | | "5759867" "5759920" "5763316" "5891799" "6037228" "6140183" | | |
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| 4901 ((438/197) or (438/199) or (438/216) o. (438/265) or (438/275) or (438/585) or (438/586) or (438/591) or (438/595) or (438/902)).CCLS. | | 2003/02/02 13:58 |
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